



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

: Mail Stop AF

In re application of : **Confirmation No. 4795**  
Yoshiko KOBAYASHI et al. : Docket No. 2002-0040A  
Serial No. 10/031,172 : Group Art Unit 1762  
Filed January 17, 2002 : Examiner Elena Tsoy

# A PROCESS FOR FORMING A MULTI-LAYER COATING FILM

## RESPONSE TO FINAL REJECTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Final Rejection dated September 9, 2003, the period for response having been extended for three months by the attached petition.